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APPLICATION NO.		FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/536,721		03/28/2000	Toshiaki Hongoh	PM 266959	5386
<b>ò</b> 0ò	7590	05/17/2002			
PILLSBURY WINTHROP, LLP P.O. BOX 10500				EXAMINER	
MCLEAN,		)2		CROWELL, ANNA M	
				ART UNIT	PAPER NUMBER
				1763	9
				DATE MAILED: 05/17/2002	1

Please find below and/or attached an Office communication concerning this application or proceeding.

			MF=9				
		Application No.	Applicant(s)				
		09/536,721	HONGOH, TOSHIAKI				
	Office Action Summary	Examiner	Art Unit				
		Michelle Crowell	1763				
Period for	- The MAILING DATE of this communication app r Reply	ears on the cover sheet with the o	correspondenc address				
A SHO THE M - Extens after S - If the I - If NO - Failure - Any re	DRTENED STATUTORY PERIOD FOR REPLY MAILING DATE OF THIS COMMUNICATION. sions of time may be available under the provisions of 37 CFR 1.13 SIX (6) MONTHS from the mailing date of this communication. period for reply specified above is less than thirty (30) days, a reply period for reply is specified above, the maximum statutory period we to reply within the set or extended period for reply will, by statute, uply received by the Office later than three months after the mailing dipatent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be ting within the statutory minimum of thirty (30) day will apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	mely filed ys will be considered timely. the mailing date of this communication. ED (35 U.S.C. § 133).				
1)	Responsive to communication(s) filed on	·················					
2a) <u></u> □	This action is <b>FINAL</b> . 2b)⊠ Thi	is action is non-final.					
3)	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.						
·	on of Claims						
	Claim(s) <u>1-17</u> is/are pending in the application						
	la) Of the above claim(s) <u>10-17</u> is/are withdraw	n from consideration.					
	Claim(s) is/are allowed.						
	Claim(s) <u>1-9</u> is/are rejected.						
·	Claim(s) is/are objected to.						
•	Claim(s) are subject to restriction and/or on Papers	r election requirement.					
9)□ T	he specification is objected to by the Examiner	r.					
10)∐ T	The drawing(s) filed on is/are: a)□ accep	oted or b)⊡ objected to by the Exa	miner.				
_	Applicant may not request that any objection to the	= ' '					
11) The proposed drawing correction filed on is: a) □ approved b) □ disapproved by the Examiner.							
40) C =	If approved, corrected drawings are required in reply to this Office action.						
12) The oath or declaration is objected to by the Examiner.							
•	nder 35 U.S.C. §§ 119 and 120						
13)⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).							
, _	☑ All b)☐ Some * c)☐ None of:						
	1. Certified copies of the priority documents						
	2. Certified copies of the priority documents						
<ul> <li>3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).</li> <li>* See the attached detailed Office action for a list of the certified copies not received.</li> </ul>							
14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).							
a) ☐ The translation of the foreign language provisional application has been received. 15)☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.							
Attachment(s)							
2) Notice	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449) Paper No(s) 3	5) Notice of Informal	y (PTO-413) Paper No(s) Patent Application (PTO-152)				

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### **DETAILED ACTION**

### Election/Restrictions

1. Applicant's election without traverse of Claims 1-9 in Paper No. 8 of the interview summary is acknowledged.

## Claim Rejections - 35 USC § 112

- 2. The following is a quotation of the second paragraph of 35 U.S.C. 112:
  - The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.
- 3. Claims 2 and 3 rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

Claim 2 recites, "a water component being released from the other components in the process chamber". This portion of the claim is unclear to the examiner.

# Claim Rejections - 35 USC § 102

4. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 5. Claims 1,2, and 4-7 are rejected under 35 U.S.C. 102(b) as being anticipated by Ishii et al. (U.S. 5,698,036).

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Referring to Figures 14-19, column 11, line 46- column 12, line 67, and column 14, line 60 – column 15, line 13, Ishii discloses a microwave plasma processing apparatus comprising a microwave introducing port 81 which introduces microwaves into the processing container 4 (processing chamber), dielectric material 80 for shortening the guide wavelength of the microwave (wavelength reducing member), a flat antenna member 44 (slot electrode) to form an electrostatic field in the processing space S, a dielectric-material accommodation portion 82a (antenna accommodating member) of the antenna covering member 82 which covers the dielectric material 80, and a ceramic protective plate 92 (dielectric material member) formed on the lower surface of the antenna member 44 that protects the antenna member 44 from plasma.

On the upper surface of the antenna covering member 82, cooling fins 84 (first temperature control device), cooling fans, or cooling jacket may be used to cool the flat antenna member 44, dielectric material 80, and dielectric accommodating portion 82a. Also, a cooling jacket 18 (second temperature control device) in support frame 8 cools the processing wafer.

### Claim Rejections - 35 USC § 103

- 6. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 7. Claim 3 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ishii et al. (U.S. 5,698,036).

Regarding the temperature of the temperature control device, it would have been obvious

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to one of ordinary skill in the art at the time of the invention to maintain the temperature of the slot electrode in a predetermined range of 60-80°C. This would prevent the slot electrode from physical deterioration and yield optimum processing conditions. Where the general conditions of a claim are disclosed in the prior art, it is not inventive to discover the optimum or workable ranges by routine experimentaion. In re Aller, 220 F.2d 454, 456, 105 USPQ 233, 235 (CCPA 1955).

8. Claim 8 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ishii et al. (U.S. 5,698,036) in view of Yamazaki (Japanese Patent Publication 10-060657).

Ishii fails to teach a temperature control device for the periphery of a dielectric material member.

Referring to solution, Yamazaki teaches a microwave plasma processing apparatus which supplies a cooling gas (third temperature control device) between top plate 31 and dielectric substance window 30 (dielectric material member). It would have been obvious to one of ordinary skill in the art at the time of the invention to provide the dielectric material member of Ishii with the temperature control device as taught by Yamazaki. This would prevent a thermal destruction of the dielectric material member.

9. Claim 9 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ishii et al. (U.S. 5,698,036) as applied to claims 1, 2, and 4-7 above, and further in view of Yamazaki (Japanese Patent Publication 01-036985).

Ishii fails to show the temperature control arrangement for controlling the temperature of the side wall.

Referring to the abstract and constitution, Yamazaki show a microwave plasma CVD apparatus which uses a heater 110 and a cooling pipe 111 (temperature control device) to control the temperature of the side wall. It would have been obvious to one of ordinary skill in the art at the time of the invention to provide the side wall of Ishii with the temperature control device as taught by Yamazaki. This would prevent the deterioration of the film quality due to the discharge of an impure gas from the inner wall.

### Conclusion

10. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Michelle Crowell whose telephone number is (703) 305-1956. The examiner can normally be reached on M-F (8:00 - 4:30).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory Mills can be reached on (703) 308-1633. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 872-9310 for regular communications and (703) 872-9311 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0661.

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AMC WWW May 13, 2002

GREGORY MILLS
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 1700

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